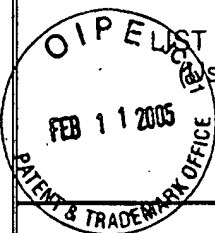


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*Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date If Appropriate
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							Yes	No
	AM							
	AN							

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AR		Wolf et al., Silicon Processing for the VLSI Era, 1986, Lattice Press, Volume 1, Pages 1 and 2.
AS		
AT		

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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.